

OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet**Applicant Information**

Applicant Authority type:: Inventor
 Primary Citizenship Country:: Japan
 Status:: Full Capacity
 Given Name:: Tsuyoshi
 Family Name:: NISHIZAWA
 City of Residence:: Nishishirakawa-gun
 Country of Residence:: Japan

Correspondence Information

Correspondence Customer Number:: 25944

Application Information

Application Type:: National Phase
 Subject Matter:: Utility
 CD-ROM or CD-R:: None
 Title:: METHOD FOR PRODUCING SILICON
 EPITAXIAL WAFER AND SILICON
 EPITAXIAL WAFER
 Attorney Docket Number:: 126273
 Suggested Drawing Figure:: 1
 Total Drawing Sheets:: 12
 Small Entity:: No

Representative Information

Attorneys associated with Customer No. 25944.

Domestic Priority Information			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Stage of	PCT/JP2004/008725	06/21/04

Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2003-182615	06/26/03	Yes
Assignee Information			
Assignee Name::		Shin-Etsu Handotai Co., Ltd.	
Street of mailing address::		4-2, Marunouchi 1-chome, Chiyoda-ku	
City of mailing address::		Tokyo	
Country of mailing address::		Japan	
Postal or Zip Code of mailing address::		100-0005	